



THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 1853

Shoriki NARITA et al.

Docket No. 2001_1876A

Serial No. 10/019,700/

Group Art Unit 2825

Filed January 2, 2002

Examiner Igwe U. Anya

Mail Stop: ISSUE BRANCH

BUMP FORMING APPARATUS FOR : CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, CHARGE REMOVAL METHOD FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, CHARGE REMOVING UNIT FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, AND CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE

REQUEST FOR ACKNOWLEDGMENT OF INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicants hereby request that the Information Disclosure Statement filed with the Patent Office on May 18, 2004 be considered by the Examiner. Applicants also request that the Examiner return an initialed copy of the PTO 1449 form which was filed as part of said Information Disclosure Statement. A courtesy clean copy of the PTO 1449 form is enclosed, along with a copy of the Information Disclosure Statement and a date-stamped postal receipt

Jh.

card, by the U.S. PTO, as *prima facie* evidence that the Information Disclosure Statement was received by the U.S. PTO on May 18, 2004.

Respectfully submitted,

Shoriki NARITA et al.

W. Douglas Hahm

Registration No. 44,142 Attorney for Applicants

WDH/asd Washington, D.C. 20006-1021 Telephone (202) 721-8200 Facsimile (202) 721-8250 August 5, 2004



ATTY DOCKET #: 2001-1876A

Confirmation No. 1853

OUR REF: 2001 1876A/WDH/00177

Applicant:

Shoriki NARITA et al.

Serial No.:

10/019,700

e: January 2, 2002 Title: BUMP FORMING APPARATUS FOR CHARGE APPEARANCE SEMICONDUCTOR

SUBSTRATE, CHARGE REMOVAL METHOD FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, CHARGE REMOVING UNIT FOR CHARGE APPEARANCE SEMICONDUCTOR SUBSTRATE, AND CHARGE APPEARANCE

SEMICONDUCTOR SUBSTRATE

Receipt of the following papers is acknowledged:

1. Information Disclosure Statement

2. PTO-1449 Form with Supplementary European Search Report and 3 references attached

Date: May 18, 2004

Attorney: WDH/gtg

[Check No._

Due Date: N/A

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEE FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975.

BEST AVAILABLE COPY



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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to the provisions of 37 CFR 1.56, 1.97 and 1.98, Applicants request consideration of [X] the references listed on attached form PTO-1449 and/or [] the additional information identified below in paragraph 3. A legible copy of each reference listed on the form PTO-1449 and each U.S. patent application listed below is enclosed, except a copy is not provided for each reference previously cited by or submitted to the Patent Office in prior parent application Serial No.

1a. [] This Information Disclosure Statement is submitted:

within three months of the filing date (or of entry into the National Stage) of the above-entitled application, or

before the mailing of a first Office Action on the merits or the mailing of a first Office Action after the filing of an RCE,

and thus no certification and/or fee is required.

1b. [X] This Information Disclosure Statement is submitted

after the events of above paragraph 1a and prior to the mailing date of a final Office Action or a Notice of Allowance or an action which otherwise closes prosecution in the application, and thus:

- (1) [X] the certification of paragraph 2 below is provided, or
- (2) [] the fee of \$180.00 specified in 37 CFR 1.17(p) is enclosed.
- 1c. [] This Information Disclosure Statement is submitted:

after the mailing date of a final Office Action or Notice of Allowance or action which otherwise closes prosecution in the application, and prior to payment of the issue fee, and thus:

the certification of paragraph 2 below is provided, and

the fee of \$180.00 specified in 37 CFR 1.17(p) is enclosed.

- 2. It is hereby certified
 - a. [X] that each item of information contained in this Information Disclosure
 Statement was first cited in any communication from a foreign patent office in a
 counterpart foreign application not more than three months prior to the filing of
 the Statement, or
 - b. [] that no item of information contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application and, to the knowledge of the person signing the certification after making reasonable inquiry, was known to any individual designated in §1.56(c) more than three months prior to the filing of the Statement.

- 3. [] Consideration of the following list of additional information (including any copending or abandoned U.S. application, prior uses and/or sales, etc.) is requested.
- 4. [X] For each non-English language reference listed on the attached form PTO-1449, reference is made to:
 - a. [] a full or partial English language translation submitted herewith,
 - b. [] a foreign patent office search report (in the English language) submitted herewith,
 - c. [] the concise explanation contained in the specification of the present application at page,
 - d. [X] the concise explanation set forth in the attached English language abstract,
 - e. [] the concise explanation set forth below or on a separate sheet attached to the reference:
- 5. [X] A foreign patent office search report citing one or more of the references is enclosed.
- 6. [X] Statement Under 37 CFR 1.704(d)

Each item of information contained in the Information Disclosure Statement was cited in a communication from a foreign Patent Office in a counterpart application, and this communication was not received by any individual designated in §1.56(c) more than thirty days prior to the filing of the Information Disclosure statement.

Respectfully submitted,

Shoriki NARITA et al

W. Douglas Hahm

Registration No. 44,142 Attorney for Applicants

WDH/gtg Washington, D.C. 20006-1021 Telephone (202) 721-8200 Facsimile (202) 721-8250 May 18, 2004

Sheet 1 of 1			1 1								
FORM PTO 1449 (modified)				1 0004	SERIAL NO. 2001-1876A 10/019,700						
U.S. DEPARTMENT OF COMMERCE PE C											
LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)					APPLICANT Sporiki NARITA et al. SelLing Date GROUP						
Date Submitted to PTO: May 18, 2004					Seling date Seanuary 2, 2002			GROUP 2825			
TENT & TRAD U.S. PATENT DOCUMENTS											
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE		NAME	Ct	ASS	SUBCLASS	FILING DATE IF APPROPRIATE		
	AA	5,341,979	08/1994		Gupta]					
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FOREIGN PATENT DOCUMENTS											
		DOCUMENT NUMBER	DATE		COUNTRY CLASS SUBCLASS TRANSLATION YES NO						
A	AJ	11168074	06/1999		JP				Abstract		
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OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)											
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